DIAMOND-LIKE CARBON FILMS as WEAR-PROTECTIVE COATINGS on MEDIA and HEAD SLIDERS

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ABSTRACT: To achieve ultra-high recording density, flying heights of less than one micro-inch are required which lead to a tribo-logy of the HDI (head-disk interface) limiting disk drive design. Various amorphous diamond-like or DLC type carbon films have been developed for wear protection. At first pure carbon (Cl sputtered films were used, followed by C:H (hydrogenated carbon) and C:N (nitrided carbon) films with generally superior wear performance. Because of the near- or quasi-contact nature of the wear process, we have used mainly (CDT) CONTINUOUS DRAG TESTING for our evaluations, along with identifying bond character, nanohardness, microscopies of surfaces and bulk of films etc., to establish the nature of initiation of the wear. Results on C:H will also be given to supplement results for pure C and C:N films. Differences in process and composition will control bond character, the crystal structure (or lack of it), surface roughness etc. at the HDI and is considered.

INTRODUCTION

Briefly we consider wear performance of pure C and C:N films in direct contact at HDI, consistent with quasi-contact at HDI. Total structure (atomic and electronic) is desired to establish the nature of initiation of the wear. Results on C:H will also be given to supplement results for pure C and C:N films. Differences in process and composition will control bond character, the crystal structure (or lack of it), surface roughness etc. at the HDI and is considered.

CHARACTER of DLC FILMS

i) Atomic Array in DLC Films. As a rule, DLC films consist of mixed crystalline and amorphous (may be nanocrystalline) C phases. Relative phase mix depends on conditions of sputtering (partial pressures of sputter gases, temperature of substrate etc. and the sputter method used (DC Magnetron, RF Diode, Facing Target Sputtering (FTS) etc.) Crystal phases in films are sparsely distributed in amorphous matrix yielding a diffraction pattern of weak rings superposed on a strong centrally located background as in TEM or transmission electron microscope diffraction.

ii) Electronic Bond Character in DLC Films. Elemental composition and bond character of DLC films are determined by X-ray photoelectron spectroscopy (XPS), Auger Electron Spectroscopy (AES), and recently Electron Energy Loss as Spectroscopy (EELS) [1]. Results obtained may be used to evaluate composition profiles, nature of bonding such as relative sp³/sp² bond ratio, density of film, etc. EELS data [2] for graphite, films of C and C:N deposited by FTS are shown in Fig. 1 indicating a C:N film exhibits a much smaller sp² bond peak at 285 eV and thus much greater sp³/sp² bond ratio than a pure C film.

Estimates of relative sp³/sp² bond ratios by AES and XPS show a good agreement with EELS [2]. (Note --EELS provides simultaneous bond characterizations + high resolution microscopy by TEM.) Fig. 2 hence
Fig. 1. The EELS carbon (K-edge) spectra of graphite and films of pure C and C:N sputtered by FTS [2].

shows a TEM micrograph of DC Magnetron sputtered pure C film; note graphite nano-particles. FTS C:N films exhibit much greater micro-structural uniformity compared to the pure C film (Fig. 2) as is expected for a material with higher sp³/sp² bond ratio (Fig. 1) and is a general result [3].

Fig. 2. TEM micrograph (10⁵ X) of pure DLC carbon (DC Magnetron) on a commercial disk; note nano-particles of graphite (C. Leu).

A critical factor is the 'surface roughness' or smoothness. Fig. 3 shows AFM images of the air-bearing surface of a 70% head slider, (a) uncoated and (b) subsequently coated with 5.0 nm of pure C/FTS. As can be seen, the DLC coating considerably reduces 'roughness' of head slider surface. A recent report [4] on continuous drag (CDT) tests of uncoated, C-coated and C:N-coated head sliders on commercial DLC coated disks showed that after 23K cycles of CDT, C:N coated sliders suffered least of damage of the three types with a significantly smoother off-track surface as well.

Fig. 3. AFM images of air bearing surfaces of (a) uncoated and (b) subsequently coated (5 nm) with a pure C(FTS) film [4].

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iii) Surface Roughness Features. Surface roughness and conformation of mating surfaces of the HDI have important effects on wear performance of DLC films.
Measurements were performed of initial take-off velocities of a number of head sliders from disks coated with varying contents of the DLC coating. Films were deposited on standard 'commercial' disk substrates at various partial pressures $P(N_2)$ of $N_2$ in an Ar gas mixture of total pressure 10 mtorr. All tests were done at a radius of 0.9" with 70% sliders. The results shown in Fig. 4 indicate a definite monotonic decrease in take-off velocity with $N_2$ gas partial pressure implying an increasingly smoother surface with increasing C:N film content.

![Graph showing initial take-off velocity (RPM) vs $P(N_2)$ (mtorr) for $N_2$ in Ar mixture of total gas pressure = 10 mtorr.](image)

**Fig. 4.** Initial take-off velocity (RPM) at $r = 0.9"$ vs $P(N_2)$ (mtorr) of $N_2$ in Ar mixture of total gas pressure = 10 mtorr[5].

Optical Properties. Optical property measurements allow evaluations of the optical band gap, $E_g$, which also confirmed that sp$^3$ type bonding in C:N films is greater than in pure C films[6,7].

**Fig. 5.** Load($\mu N$) vs Depth($\mu m$) in which curves show effect of $P(N_2)$ and hence $N_2$ on the modulus of a DLC film. The C:N film is harder than a plain C film without nitrogen. Waviness of curves is due to cracking of the films[2].

Important considerations in DLC film wear performance are hardness and elastic compliance. To compare these characteristics for DLC of C and C:N type coatings, continuous nano-indentation tests were performed with a Triboscope TM. The Triboscope is load-controlled of sensitivity 1.8 nanoNewtons and a depth resolution of 0.2 nm. When attached to a conventional AFM it enables one to scan a surface before indentation and to image the resulting indent immediately after an indentation. The indenter tip used was a standard scanning tunneling microscope (STM) pyramidal boron-doped diamond tip with a radius of 100 nm (included 72° angle).

Measurements of hardness and modulus were performed on C and C:N films ranging in thickness on head sliders. Data[2] for 100 nm thick C and C:N coatings obtained with Triboscope TM are shown in Fig. 5. The hardness and modulus were determined from these data by the method of Doerner and Nix[8] shown in Fig. 6.
Using the upper one-third of an unloading curve slope, a reduced MODULUS \( E^* \) and the HARDNESS \( H \) are given by

\[
E^* = \left( \sqrt{\frac{\pi}{4}} \right) \frac{(dP/dh)}{A}
\]

and

\[
H = \frac{P_{\text{max}}}{A}
\]

where \( A \) = area of indent
\( = \pi(2R-h_C)^2 \)
\( h_C \) = contact depth
\( = h_{\text{max}} - \xi P_{\text{max}}/(dP/dh) \)
\( dP/dh \) = linear fit slope of upper 1/3 of unload curve
\( R \) = radius of indenter
\( h_{\text{max}} \) = maximum penetration depth
\( P_{\text{max}} \) = maximum load

and \( \xi \) is a parameter that depends on the indenter tip shape.

The results of [2] give 427 GPa for the C:N modulus which is much greater than the pure C modulus, which is 272 GPa; the modulus of the head slider material = 330GPa. The hardness for these three materials is 23.5 GPa for C:N, 21.5 GPa for pure C, and 18.5 GPa for the \( \text{Al}_2\text{O}_3-\text{TiO}_3 \) head slider.

TRIBOLOGY OF DLC FILMS

The obvious properties that are required of wear-protective films are to: i) be as thin as possible, ii) have no asperities for mechanical contact, iii) resist coating wear and inflict no slider "wear", iv) have minimum friction, v) protect media from corrosion, exhibiting good tribochemical behavior, vi) bond to media, not to slider, and vii) have high hardness (yield strength) and fracture toughness.

In regard to (i), reproducible, pinhole-free 9.0nm thick DLC films of pure C and C:N can be deposited without need of adhesion underlayers. Thinner films (7.5-5.0nm) low in yield have been deposited, but may be improved using an adhesion underlayer and high deposition energy.

In regard to (ii), Yeh et al[5] showed that the initial 'take-off velocity' decreases with increase in nitrogen gas pressure \( P(N_2) \), as in Fig. 4. This implies a smoother surface for C:N films on disks compared to that of pure C films consistent with results shown in the Fig. 3 for slider surfaces.

With respect to (iii), Yeh [3] and Wang et al[9] have shown that C and C:N films may be sputtered with kinetic friction coefficient in the range 0.12-0.20 and by care in processing develop coefficient values of 0.08-0.1 for C:N films. In case (iv), Torng[10] has shown that C:N films have superior corrosion resistance by no reactions in various acid solutions: \( \text{MCl, HNO}_3-\text{HCl-CH}_3\text{COOH, HCl-HNO}_3 \), and HF. For (v), C:N films exhibit no delaminations as-deposited, while pure C films tend to 'wrinkle' on deposition due to a compressive stress state developed during the deposition[10].

As regards (vi), Wang et al[4,9] have used CDT to study wear on sliders to show wear resistance in direct contact under various conditions or combinations that form the HDI, given as follows: Wear performance studies were made by CDT (direct contact test)
of uncoated and coated 70% head-sliders on various lubricated and unlubricated standard commercial C-coated 3½" disk media. The data results in Fig. 7 & 8 show: wear-resistance of C:N-coatings are in fact superior to those of C- and C:H-coatings. Wang et al[4] reported on the wear resistance of uncoated and of C- and C:N-coated (9.0nm) sliders on unlubricated, commercial C:H-coated media. The results[4] in Fig. 8 showed that uncoated sliders had the highest kinetic friction and C:N-coated sliders had the lowest after 20K cycles.

In all cases, best wear test performance was by C:N-coated head-sliders with uncoated sliders having poorest. Note: pure C-coated sliders performed about as well as C:N-coated sliders when deposited by FTS. Fresh heads were used for each CDT run, performed at a maximum energy dissipation rate. Also, Zou et al[11] reported quasi-contact test results showing C:N coatings performed better the higher the nitrogen content. Similar type results are reported by Lal et al[10].

Fig. 7(a). Coefficient of kinetic friction vs revolutions with and without C-coated sliders. C-coated disks without lubricant. □ uncoated slider; ◇ slider C-coated (15.0nm), △ slider coated (30.0nm C) by DC magnetron; ○ slider with 15.0nm C by FTS...

(b) kinetic friction vs number revolutions with and without C-coated sliders; C-coated disks[9]

Fig. 8. The coefficient of kinetic friction vs revolutions for heads coated with and without pure C, and C:N coating on heads deposited by FTS. Disk media were C:H-coated without lubricant[4].

The physical character of initial wear damage features in the DLC films is significant. E.g., in C:H films initial damage appears as a random distribution of fine hard particles of sub-micron size along the wear track; Cf. Fig. 9[4]. For C:N films[3], the initial wear damage is similar to an adiabatic shear banding due to plastic flow about the wear track with gradual thinning along the track; Fig. 10. Note: apparent wear marks in Fig. 10(b) are an effect of disk texture, while (a) exhibits an early stage flow damage. Comparably the initial damage in pure C DC magnetron sputtered films appeared as ductile tearing of sub-micron to micron size, randomly distributed around the wear track, added wear.
occurring by enlargement of worn sites during repeated wear cycles.

Fig. 9. SEM micrograph of a wear track on a C:H-coated disk using an uncoated slider after CDT.

Fig. 10. SEM micrographs of a wear track on a C:N coating with a low sp3/sp2 after 5K cycles, b) C:N with high sp3/sp2 after 9K cycles using uncoated sliders.

CONCLUSIONS

We conclude that amorphous C:N is a superior wear-protective coating for thin film media and head sliders because C:N = 1) has high hardness, high modulus plus fracture toughness correlating with a high sp3/sp2 bond ratio, 2) shows exceptional corrosion resistance, 3) has good surface smoothness + a coefficient of friction attainable in the 0.15-0.20 range, 4) has a homogeneous composition and a uniform structure which reduce a tendency to form local stress concentrations that may initiate submicron catastrophic wear damage, 5) a minimal environmental problem when compared to C:H formed by chemical vapor deposition, and 6) can be up -graded by increasing physical density and sp3 bonding by optimizing deposition processes; e.g., a RF, or FTS etc. sputtering method.

REFERENCES